

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DT04 Rec'd PCT/PTO

10/511557

15 OCT 2004
JLB

Applicant(s): Mund & Leib
Serial No.: Not Yet Assigned
Filed: Herewith
For: PROCESS FOR JOINING SUBSTRATES, & COMPOSITE ELEMENT
Art Unit: Not Yet Assigned
Examiner: Not Yet Assigned
Confirmation No.: Not Yet Assigned
Customer No.: 27623

Attorney Docket No.: 2133.062USU

Date: October 15, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with applicants' duty of disclosure under 37 C.F.R. §1.56, we are enclosing form PTO-1449 listing information that may be material to the patentability of this application.

It should be understood that attention has been called to the citations that have been deemed to be pertinent to the claimed present invention. In concluding what was pertinent, the criteria employed was considered most appropriate in light of the invention shown in the present application. However, the Examiner or others may deem some other criteria to be just as appropriate or more appropriate. Therefore, the

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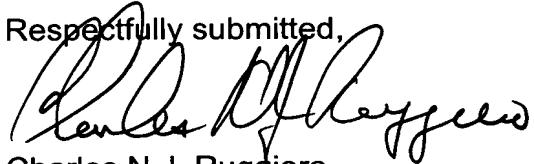
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Examiner is respectfully urged to review the listed citations and to make the usual careful independent search for other prior art that may be pertinent.

Since this Information Disclosure Statement is being filed with the filing of this application, no petition or fee is required.

Applicants respectfully request favorable consideration and that this application be passed to allowance.

Respectfully submitted,



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Sheet 1 of 1 OCT 2004

CUSTOMER NO.: 27622

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)			Docket Number (Optional) 2133.062USU	Application Number Not Yet Assigned		
			Applicant Mund and Leib			
			Filing Date Herewith	Group Art Unit Not Yet Assigned		
U. S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	5,895,233	4/20/99	Higashi et al.	438	107	
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
						YES
	0 280 905 A2	9/7/88	Europe			X
	DE10222609.1A1	5/23/02	Germany			X
	DE10222958.9A1	5/23/02	Germany			X
	DE10222964.3A1	5/23/02	Germany			X
	DE10252787.3A1	11/13/02	Germany			X
	DE10301559.0A1	10/30/03	Germany			X
OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)						
	XP-10232226A-1, Anodic Bonding Technique Under Low-Temperature and Low-Voltage Using Evaporated Glass, Woo-Beom Choi et al., 9 th Int'l Vacuum Microelectronics Conference, St. Petersburg 1996, pgs 427-430					
EXAMINER	DATE CONSIDERED					
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						